



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Yoshimi SATO et al. :
Serial No. 10/665,143 : **Attn: APPLICATION BRANCH**
Filed September 22, 2003 : Attorney Docket No. 2003_1356

COATING SOLUTIONS FOR USE IN
FORMING BISMUTH-BASED
FERROELECTRIC THIN FILMS AND
A METHOD OF FORMING BISMUTH-
BASED FERROELECTRIC THIN FILMS
USING THE COATING SOLUTIONS : **Confirmation No. 5804**

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated March 18, 2003 in the parent application, please
amend the present application as follows: